SIEMENS

In re Application of:

PATENT Attorney Docket No. 2002P08684WOUS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Title	METHOD FOR THE DEPO	SITI	ON OF AN ALLOY	ON A SUBSTRATE
Filed:	June 17, 2005)	Confirmation No.:	6840
Serial No.:	10/539,938)	Examiner:	W. T. Leader
Inventor:	Reiner Anton et al.)	Group Art Unit:	1795

Commissioner For Patents

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Response Under 37 CFR 1.111

In response to the Office Action mailed March 30, 2009, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

(please proceed to the next page)